

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1. (CURRENTLY AMENDED) An apparatus, comprising:
a multilayer structure comprising:
a free layer;
~~having~~ an antiferromagnetic layer between ~~[[a]]~~ first and second ~~layer~~ layers, the
first and second layers neighboring the antiferromagnetic layer, the antiferromagnetic
layer having exchange anisotropy that helps pin the magnetization direction of the first
layer and helps pin the magnetization direction of the second layer, such that the first
layer comprises a pinned layer and the second layer comprises a pinned keeper layer, the
pinned layer producing first pole densities and resulting first field that are approximately
canceled by a second field within the free layer resulting from second pole densities
produced by the pinned keeper layer, wherein said the magnetization direction of said the
first layer is antiparallel to said the magnetization direction of said the second layer.
3. CANCELED
4. CANCELED
5. CANCELED
6. (CURRENTLY AMENDED) The apparatus of claim ~~[[5]]~~ 1 wherein the resistance associated with each of the layers of said larger multilayer structure is such that most of the current flow through said sensor flows through said antiferromagnetic layer.
7. (ORIGINAL) The apparatus of claim 6 wherein said current flow is centered along the thickness of said antiferromagnetic layer.

8. ((CURRENTLY AMENDED) The apparatus of claim [[5]] 1 wherein the resistance associated with each of the layers of said larger multilayer structure are such that more current flows through said sensor outside said antiferromagnetic layer than inside said antiferromagnetic layer.

9. (ORIGINAL) The apparatus of claim 8 wherein said antiferromagnetic layer material is an oxide.

10. (CURRENTLY AMENDED) The apparatus of claim [[5]] 1 wherein said pinned layer and/or said pinned keeper layer is a hard magnetic layer.

11. (CURRENTLY AMENDED) An apparatus, comprising:
a) a disk; and
b) a head configured to be disposed over said disk, said head comprising, a multilayer structure, said multilayer structure comprising:
a free layer;
having an antiferromagnetic layer between [[a]] first and second layer
layers, the first and second layers neighboring the antiferromagnetic layer, the
antiferromagnetic layer having exchange anisotropy that helps pin the
magnetization direction of the first layer and helps pin the magnetization direction
of the second layer, such that the first layer comprises a pinned layer and the
second layer comprises a pinned keeper layer, the pinned layer producing first
pole densities and resulting first field that are approximately canceled by a second
field within the free layer resulting from second pole densities produced by the
pinned keeper layer, wherein said magnetization direction of said first layer is antiparallel to said magnetization direction of said second layer.

13. CANCELED

14. CANCELED

15. CANCELED

16. (CURRENTLY AMENDED) The apparatus of claim ~~[[15]]~~ 11 wherein the resistance associated with each of the layers of said larger multilayer structure is such that most of the current flow through said sensor flows through said antiferromagnetic layer.

17. (PREVIOUSLY PRESENTED) The apparatus of claim 16 wherein said current flow is centered along the thickness of said antiferromagnetic layer.

18. (CURRENTLY AMENDED) The apparatus of claim ~~[[15]]~~ 11 wherein the resistance associated with each of the layers of said larger multilayer structure are such that more current flows through said sensor outside said antiferromagnetic layer than inside said antiferromagnetic layer.

19. (PREVIOUSLY PRESENTED) The apparatus of claim 18 wherein said antiferromagnetic layer material is an oxide.

20. (WITHDRAWN) A method comprising:
cooling a multilayer structure having an antiferromagnetic layer from a temperature above an antiferromagnetic blocking temperature to a temperature below said antiferromagnetic blocking temperature while a first magnetic field is established within a first layer to pin the magnetization direction of said first layer and while a second magnetic field is established within a second layer to pin the magnetization direction of said second layer.

21. (WITHDRAWN) The method of claim 20 wherein said first field is antiparallel to said first field.

22. (WITHDRAWN) The method of claim 21 wherein said first and second fields are formed by directing a current through said multilayer structure, said first and second fields antiparallel to each other.

23. (WITHDRAWN) The method of claim 21 wherein said first and second fields are at least partially formed by directing more current outside said multilayer structure than inside said multilayer structure.

24. (WITHDRAWN) The method of claim 23 further comprising applying an external magnetic field, said external magnetic field fully forming said first and second magnetic fields when combined with fields produced by said current.